

Stu

Docket No.: 006217 USA/Consilium/Consilium

PATENT/OFFICIAL

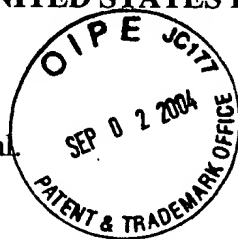
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Nicholas A. WARD et al.

Serial No. 09/927,444

Filed: August 13, 2001



:  
:  
:  
:  
:  
:

Group Art Unit: 2125

Examiner: Sean P. Shechtman

For: DYNAMIC CONTROL OF WAFER PROCESSING PATHS IN SEMICONDUCTOR  
MANUFACTURING PROCESSES

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This submission does not constitute a representation that a search has been made or that no better art exists and does not constitute an admission or representation that any of the listed

**Serial No. 09/927,444**

documents is material or constitutes prior art. If it should be determined that any of the listed documents does not constitute prior art under the United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such document.

No fee is believed to be required, however, the Commissioner is hereby authorized to charge any additional fees that may be required for this submission, or credit any overpayment to deposit account no. 08-0219.

Respectfully submitted,

Wilmer Cutler Pickering Hale and Dorr LLP

A handwritten signature in black ink, appearing to read "S M Alter".

Scott M. Alter

Registration No. 32,879

The Willard Office Building  
1455 Pennsylvania Avenue, NW  
Washington, DC 20004  
TEL (202) 942-8428 SMA/mgm  
FAX (202) 942-8484  
Date: 9/2/04

**INFORMATION DISCLOSURE  
CITATION IN AN  
APPLICATION  
(PTO-1449)**

ATTY. DOCKET NO.  
006217 USA/  
Consilium/Consilium

SERIAL NO.  
09/927,444

APPLICANT  
Nicholas A. WARD et al.

FILING DATE  
August 13, 2001

GROUP  
2125

**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,975,994	11/02/99	Sandhu et al.			06/11/97
	6,113,462	09/05/00	Yang			12/18/97
	6,277,014	08/21/01	Chen et al.			10/09/98

**FOREIGN PATENT DOCUMENTS**


**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER	DATE CONSIDERED
----------	-----------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.